

WHAT IS CLAIMED IS:

1. A method for manufacturing an organic electroluminescence panel having an organic electroluminescence element and a terminal
5 for external connection for driving the organic electroluminescence element, the organic electroluminescence element having an organic layer including a light emitting molecule between a lower electrode and an upper electrode, wherein

10 a laser removal layer made of a laser absorbing material is formed to cover a formation region of the terminal for external connection;

after the laser removal layer is formed, a protection film is formed to cover the organic electroluminescence element and the laser removal layer; and

15 laser light having a wavelength in an absorption wavelength range of the laser absorbing material is irradiated toward a region in which the laser removal layer is formed so that the laser removal layer and the protection film formed above the laser removal layer are removed and an upper surface of the terminal for external
20 connection is exposed.

2. A method for manufacturing an organic electroluminescence panel according to Claim 1, wherein

an organic insulating layer is formed at least partially
25 covering end portions of each of the lower electrodes formed individually for each pixel, and, simultaneously, the organic insulating layer is formed over the formation region of the terminal

for external connection as the laser removal layer.

3. A method for manufacturing an organic electroluminescence panel according to Claim 2, wherein

5 the organic insulating layer is a planarizing insulating layer containing a photosensitive material.

4. A method for manufacturing an organic electroluminescence panel according to Claim 2, wherein

10 the protection film is a laser transmitting film which allows the laser light to transmit through and is removed along with the laser removal layer when the laser light is irradiated.

5. A method for manufacturing an organic electroluminescence panel according to Claim 1, wherein

15 a plurality of organic electroluminescence elements are formed on the panel substrate; and

an organic insulating layer is formed to separate, by each lower electrode or by each upper electrode, at least a portion of 20 the organic layer of the organic electroluminescence element, and the organic insulating layer is simultaneously formed over the formation region of the terminal for external connection as the laser removal layer.

25 6. A method for manufacturing an organic electroluminescence panel according to Claim 1, wherein

the laser removal layer is a planarizing insulating layer

containing a photosensitive material.

7. A method for manufacturing an organic electroluminescence panel according to Claim 1, wherein

5 the protection film is a laser transmitting film which allows the laser light to transmit through and is removed along with the laser removal layer when the laser light is irradiated.

10